



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Leonard C. Pipes et al.	§	Art Unit:	2812
Serial No.:	10/764,751	§	Examiner:	Stanetta D. Isaac
Filed:	January 26, 2004	§	Atty Docket:	ITL.0851D1US
For:	Implanting Ions in Shallow Trench Isolation Structures	§		P15016D
		§	Assignee:	Intel Corporation

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Prior to the receipt of an office action, please amend the above-referenced patent application as follows:

Date of Deposit: February 21, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
Cynthia L. Hayden